

Patent Docket No. 50544.00003 (NVLS 387)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231, on

Date: 7/21/01

By: Aaron Wininger

In Re Application of:

Craig L. Stevens

Serial No.

09/888,017

Filed:

June 21, 2001

For:

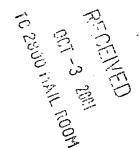
High Throughput Architecture For

Semiconductor Processing

Commissioner for Patents Washington, D.C. 20231

Examiner: Unknown

Art Unit: 2812



## INFORMATION DISCLOSURE STATEMENT

Sir:

The information listed below may be material to the examination of the above-identified application. Copies of the cited reference(s) and a completed PTO-1449 form are submitted herewith. The Examiner is requested to make this information of official record in the application.

Applicants would appreciate the Examiner's initialing and returning the Form PTO-1449, indicating that the reference(s) have been considered and made of record herein.

The Information Disclosure Statement under 37 CFR §1.97 is not to be construed as a representation that: (i) a search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

If for any reason an insufficient fee has been paid, the Commissioner is hereby authorized to charge any deficiency in payment of required fees associated with this communication to Deposit Account <u>05-0150</u>.

Dated: September 21, 2001

Respectfully submitted,

Squire, Sanders & Dempsey L.L.P.

600 Hansen Way

Palo Alto, CA 94304-1043 Telephone: 650.856.6500

Facsimile: 650.843.8777

By:

Aaron Wininger, Esq. Registration No. 45,229 Attorney for Applicant(s)